IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Cyril Cabral Jr.

Group Art Unit: 282

Serial No.: 09/686,742

Examiner: Lourdes Cruz

Filed:

Oct. 11, 2000

In Response to Office Action

Dated:

July 31, 2002

For:

NON O B SOOL

Semiconductor Structure Having In-Situ Formed

Unit Resistors and Method for Fabrication

Attorney Docket No.: 64,610-057 (YOR9-2000-0361US1)

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents,

Washington, D.C. 20231.

Date: Oct. 31, 2002

RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In response to an Office Action mailed July 31, 2002, please enter the following amendments and consider the following remarks.